



Docket No.: 1573.1006

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Re the Application of:

Osamu IEMOTO et al.

Serial No. 09/866,647

Group Art Unit: 2129

Confirmation No. 5798

Filed: May 30, 2001

Examiner: Joseph P. Hirl

For: A COMPUTER-ASSISTED EDUCATION APPARATUS AND METHOD FOR  
ADAPTIVELY DETERMINING PRESENTATION PATTERN OF TEACHING  
MATERIALS (as amended)

**COMMUNICATION**

Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

Sir:

Applicants submit herewith a copy of Japanese Office Action mailed July 25, 2006 regarding Japanese Patent Application No. 2000-398404. Japanese Application No. 2000-112327 is cited in the Japanese Office Action and is included herewith.

It is requested that the Japanese Office Action and Japanese Application No. 2000-112327 be placed in the file of the subject patent.

Respectfully submitted,

STAAS & HALSEY LLP

Date: 08/25/2006

By: Temnit Afework  
Temnit Afework  
Registration No. 58,202

1201 New York Avenue, NW, 7th Floor  
Washington, D.C. 20005  
Telephone: (202) 434-1500  
Facsimile: (202) 434-1501